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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10069511	FILING DATE 06/24/2002	CLASS 219	SUBCLASS 444.100	GAU 3742	EXAMINER Park Fugua
**APPLICANTS: Ito Yasutaka; Mashima Kazutaka;					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A 371 OF PCT/JP01/05742 07/03/2001 <i>stf</i>					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 2000-201060 07/03/2000 <i>stf</i>					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed. <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO.			
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		220253US2PCT			
Verified and Acknowledged Examiners's initials <i>stf</i>					
TITLE : Ceramic heater for semiconductor manufacturing /testing apparatus					
U.S. DEPT. OF COMM /PAT. & TM-PTO-436L (Rev. 12-94)					

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NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	
ISSUE FEE		Total Claims	
Amount Due	Date Paid	Print Claim for O.G.	
		DRAWING	
		Sheet Drwg.	Figs. Drwg.
		Print Fig.	
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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